

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: Shunichi SATO et a;/

Serial No.: 10/567,809

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For: SURFACE-EMISSION LASER DIODE AND FABRICATION PROCESS THEREOF

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**APPLICANT'S COMMENTS ON
EXAMINER'S STATEMENT OF REASONS FOR ALLOWANCE**

Sir:

Applicant appreciates the Examiner's Statement of the Reasons for Allowance attached to the Notice of Allowability dated November 9, 2009 and submits that the allowed claims recite subject matter which further supports patentability for reasons in addition to those identified in the Reasons for Allowance.

Respectfully submitted,

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I hereby certify that this correspondence is being deposited this date with the U.S. Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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January 25, 2010
Date